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**Kazuhiro AIHARA, et al.**

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**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE

**FOREIGN PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
<i>HPu</i>	9-246494	Sept. 19, 1997	JAPAN (with English abstract)				
<i>HPu</i>	8-293494	Nov. 5, 1996	JAPAN (with English abstract)				

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

<i>HPu</i>	"Optimum Electrode Materials for Ta <sub>2</sub> O <sub>5</sub> Capacitors for High- and Low-Temperature Processes", H. Matsushashi et al., Jpn. J. Appl. Phys., Vol. 33 (1994), pp. 1293-1297

EXAMINER <i>J. Mondt</i>	DATE CONSIDERED <i>Aug. 20 '01.</i>
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